Visiting Application Form in OnBase Instructions:

* VPN and an OnBase account are required to complete this process.

* Users experiencing issues with file upload/attachments should first attempt the task using the recommended browser, Firefox. If this does not solve the problem, please submit a request for assistance at help.emory.edu.

1. <u>Requesting an OnBase account:</u>

An OnBase account is required to submit Visitors' Application form on OnBase. If you do not have an OnBase Account, you can submit a Service Request at <u>help.emory.edu</u> and include the text below.

- o Name
- o NetID
- o Email Address
- Access Needed (RC HR usergroup)

2. <u>Connect to Emory VPN and Log to OnBase.</u>

You **must** be connected to Emory VPN to submit a form. If you do not have the VPN client installed, make a request through the helpdesk <u>help.emory.edu</u>. Once you are connected to the VPN

- Navigate to "imaging.emory.edu"
- Log in using NetID & Password
- If you save the URL to your bookmarks, be sure to leave out "/AppNet" in the address: Imaging.emory.edu/AppNet

3. Access the Visiting Scholar Application Form

- Select the stack icon at the top left corner 1.
- Select "New Form" from the drop-down menu 2
- Select "RC-Visiting Scholar Application Form"

• Click "PI and Visitor Information" tab and complete the form 4

| New Form | | OnBase | | | | |
|-----------------------|------------------------------|---|------------------------------|--|--|--|
| OCUMENT | Forms | Visitor Application Form | | | | |
| Document Retrieval | | visitor Application Form | | | | |
| Custom Queries | RC - Visiting Application Fo | Pl and Visitor Information Administration | • | | | |
| New Form | V II m | 0 | | | | |
| Import Document | × | PI Information | | | | |
| Documents Checked Out | | | | | | |
| ORKFLOW | | Net ID | | | | |
| Open Workflow | | School | | | | |
| | | Full Name | T | | | |
| TATUSVIEW | | | <u>^</u> | | | |
| Open StatusView | | 1/22 | | | | |
| SER | | Department | | | | |
| Locked Objects | | Email | | | | |
| | | Phone | | | | |
| | | | | | | |
| | | Administrative Contact | | | | |
| | | | | | | |
| | | Last Name | | | | |
| | | Use mixed o | ase values beginning with an | | | |
| | | First Name | | | | |

- The PI is the person inviting the visitor or the supervisor of the international employee. The PI Information and HR Department sections have autofill capabilities. Type the NetID and then "Tab" to auto complete the rest.
- Type the Last Name with mixed case (ie. Smith, not SMITH or smith)
- Red Asterisk marks a required field

4. Attaching Documents and submitting the form.

- Click on "Upload supporting documentation" to upload attachments 1.
- Click on "Save to Submit the form **2**.

| Atta |
|---------------------------------|
| Upload Supporting Documentation |
| 0 |
| Save |

Note: Clicking the "Save" button submits the form to RCRA.

5. Email Notification from OnBase: Request for additional information

If an approver (Export Controls or Research Security) requires additional information, they will send the document back to the "Department Review" queue. The submitter will receive an email notification from OnBase alerting them to process the document.

| Do To: | NotReplyOBProd@emory.edu Longo, Travis Mitchell |
|-----------------------|---|
| A | Visiting Scholar Application requires your attention. Please review the form and make any necessary changes. |
| То | retrieve this document in OnBase or move it through the workflow, click below: |
| htt | tps://imaging.emory.edu/AppNet/Workflow/WFLogin.aspx?LifeCycleID=333 |
| No x | stes from Export Control: |
| No | otes from Research Security: |
| No | otes from Dept. HR: |
| Sp En De Vis | onsor Name: LONGO,TRAVIS MITCHELL nail: TRAVIS.LONGO@EMORY.EDU :partment: OIT: BUSINESS SYSTEMS sitor Name: JIMMY CARTER |
| (| Completed. Received, thank you. I completed this. |

The submitter can provide the required information by navigating to the "Workflow" (see instructions below) or by clicking on the link in the email.

6. Access the Workflow

- Select the stack icon in the upper left corner **1**.
- Select "Workflow" 2
- A pop-up window will open (make sure to allow pop ups in your browser settings)
- Select Life Cycle View > RC Visiting Application Form > RC Department Review 3
- Active applications will appear in the "Department Review" Inbox 4.
- Sort and filter by keywords to find and select the document you want to process 5
- Make the necessary updates and click "Save" button at the bottom of the form.
- Click on "Dept Approve" button to submit the form to RCRA 6.

| ew Form | | | | | | |
|---|---|----------------------------------|-------------------|------------------------|----------------------|--------------------------|
| DOCUMENT | í | | | | | |
| Document Retrieval | L | | | | | |
| Custom Queries | | | | | | |
| New Form | | | | | | |
| Import Document | | | | | | |
| Batch Indexing | | | | | | |
| Documents Checke | ed Out | | | | | |
| WORKFLOW Open Workflow | | | | | | |
| RC - Visiting Application Form (Unity Form) - 7/7/20. | 23 - Sponsor: TLONGO2 - Visitor: - Start Date: 7/28/202: | 3 - End Date: 7/28/2023 - Google | Chrome | | | - 0 |
| | Inbox Drag a column header here to group by that column. | | | | | (|
| LIFE CYCLE VIEW WORK FOLDER | DOCUMENT DATE SPONSOR FULL NAME The contains Contains | RC - HOST DEPARTMENT | VISITOR FULL NAME | APPOINTMENT START DATE | APPOINTMENT END DATE | RC - EXPORT CONTROL STAT |
| Combined Inbox | 7/7/2023 LONGO,TRAVIS MITCHEL | L OIT: BUSINESS SYSTEMS | S KHAN, IMRAN | 7/28/2023 | 7/28/2023 | |
| RC - Research Security (0) | | L3 | | | | |
| | 2 | | | | | |
| | Items: 1 | | | | | |
| | | | | | | |
| Visitor Application Form | | | | | | |
| Sponsor and Visitor Information A | dministrative | | | | | |
| Sponsor Information | | | | | | |
| Net ID | TLONGO2 | | | | | |
| School Full Name | LONGO, TRAVIS MITCHELL | | | | | |
| 0 Note(s) | | | | | | |

7. Email Notification from OnBase: Approval

Once RCRA has approved the application, the submitter will receive an approval notification from OnBase. The notification will include notes from Export Control and Research Security.

